

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

APPLICANT: KWON, Hyung-joon EXAMINER: BAKER, Stephen M.
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ON: Method And Apparatus For Correcting C1/PI Word Errors Using
Error Locations Detected By EFM/EFM+ Decoding

Mail Stop Amendment
Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

AMENDMENT

This paper is responsive to the Office Action mailed on October 10, 2006. The Examiner is requested to enter and consider the following amendments and remarks.